

herewith, in which minor grammatical and typographical errors have been corrected.

IN THE CLAIMS:

Please substitute amended claims 1 and 3-7 as follows:

a1
sub
B2
5 1. (Amended) A multilayer piezoelectric actuator device comprising:

a multilayer structure including a plurality of piezoelectric elements and a plurality of internal electrodes, said piezoelectric elements and said internal electrodes being stacked in a stacking direction so that each of said internal electrodes is placed between adjacent ones of said piezoelectric elements;

10 a pair of external electrodes disposed on respective side surfaces of said multilayer structure, each of said external electrodes being connected to respective alternate ones of said internal electrodes; and

15 a pair of conductive members connected to said external electrodes, respectively, each of said conductive members including a free end portion that is spaced apart from and faced to said respective side surfaces of the multilayer structure.

a2
3. (Amended) The multilayer piezoelectric actuator device according to claim 1, wherein said side surfaces of the multilayer structure have respective side surface portions

a2
cont.
5 opposite to each other in a direction perpendicular to said stacking direction, and said external electrodes are fixed to said side surface portions, respectively.

4. (Amended) The multilayer piezoelectric actuator device according to claim 2, wherein said internal electrodes are alternately exposed at said side surface portions and connected to said external electrodes, respectively.

5. (Amended) The multilayer piezoelectric actuator device according to claim 1, wherein said conductive members are adapted to function as a heat sink which promotes heat radiation.

SUB B3
6. (Amended) A multilayer piezoelectric actuator device comprising:

5 a multilayer structure including a plurality of piezoelectric elements and a plurality of internal electrodes, said piezoelectric elements and said internal electrodes being stacked in a stacking direction so that each of said internal electrodes is placed between adjacent ones of said piezoelectric elements;

10 a pair of external electrodes disposed on respective side surfaces of said multilayer structure, each of said external electrodes being connected to respective alternate ones of said internal electrodes; and

15 a pair of conductive members connected to said external electrodes, respectively, each of said conductive members including a free end portion that is spaced apart from and faced to said respective side surfaces of the multilayer structure;

20 wherein said side surfaces of the multilayer structure have respective side surface portions opposite to each other in a direction perpendicular to said stacking direction, and said external electrodes are fixed to said side surface portions respectively;

wherein said internal electrodes are alternately exposed at said side surface portions and connected to said external electrodes, respectively; and

25 wherein each of said internal electrodes has a first end face which is substantially flush with one of said side surface portions and a second end face which is retracted from the other of said side surface portions.

7. (Amended) A multilayer piezoelectric actuator device comprising:

5 a multilayer structure including a plurality of piezoelectric elements and a plurality of internal electrodes, said piezoelectric elements and said internal electrodes being stacked in a stacking direction so that each of said internal electrodes is placed between adjacent ones of said piezoelectric elements;

10 a pair of external electrodes disposed on respective
side surfaces of said multilayer structure, each of said external
electrodes being connected to respective alternate ones of said
internal electrodes; and

a pair of conductive members connected to said external
electrodes, respectively, each of said conductive members
including a free end portion that is spaced apart from and faced
to said respective side surfaces of the multilayer structure;

wherein said side surfaces of the multilayer structure
have respective side surface portions opposite to each other in a
direction perpendicular to said stacking direction, and said
20 external electrodes are fixed to said side surface portions
respectively;

wherein said internal electrodes are alternately
exposed at said side surface portions and connected to said
external electrodes, respectively; and

25 wherein each of said internal electrodes has end faces
which are substantially flush with said side surface portions,
and one of said faces of each of said internal electrodes is
covered with an insulator at one of said side surface portions,
respectively.